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71 Applicant: CANON KABUSHIKI KAISHA  
 30-2, 3-chome, Shimomaruko  
 Ohta-ku Tokyo(JP)

72 Inventor: Yoshioka, Seishiro  
 2-5, Fujimino 1-chome  
 Hiratsuka-shi Kanagawa-ken(JP)  
 Inventor: Nomura, Ichiro  
 No.303,Sani Hatsu Chuorinkan 14-24,  
 Chourinkan  
 4-chome Yamato-shi Kanagawa-ken(JP)  
 Inventor: Suzuki, Hidetoshi  
 3-8-A202, Sakae-cho 2-chome  
 Atsugi-shi Kanagawa-ken(JP)  
 Inventor: Takeda, Toshihiko  
 21-1, Funabashi 2-chome  
 Setagaya-ku Tokyo(JP)  
 Inventor: Kaneko, Tetsuya  
 3-107, Shitanoya-cho Tsurumi-ku  
 Yokohama-shi Kanagawa-ken(JP)  
 Inventor: Banno, Yoshikazu  
 6-29, Mizuhiki 2-chome  
 Atsugi-shi Kanagawa-ken(JP)  
 Inventor: Yokono, Kojiro  
 2-14-308, Namiki 2-chome Kanazawa-ku  
 Yokohama-shi Kanagawa-ken(JP)

74 Representative: Blumbach Weser Bergen  
 Kramer Zwirner Hoffmann Patentanwälte  
 Radeckestrasse 43  
 D-8000 München 60(DE)

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54 **Electron-emitting device.**

57 An electron-emitting device is provided which  
 comprises a laminate comprising an insulating layer  
 (5) held between a pair of electrodes (1,2) opposing  
 each other, wherein an electron-emitting region (3)  
 insulated from said electrodes is formed at a side  
 end surface of the insulating layer (5) formed at the  
 part at which the electrodes oppose each other, and  
 electrons are emitted from said electron-emitting re-  
 gion (3) by applying a voltage between said elec-

trodes. A method for preparing the electron-emitting  
 device is also provided.

**FIG.1**

